

Title of the Invention: Simplified Reticle Stage

Removal System for an Electron

Beam System

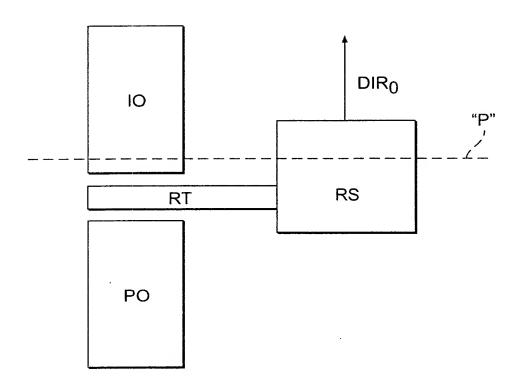


FIG. 1



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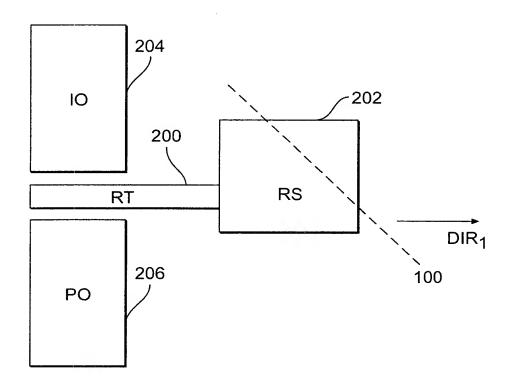
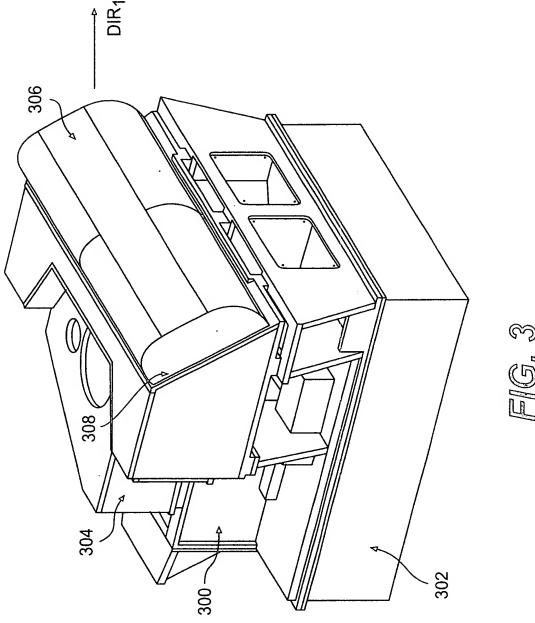


FIG. 2

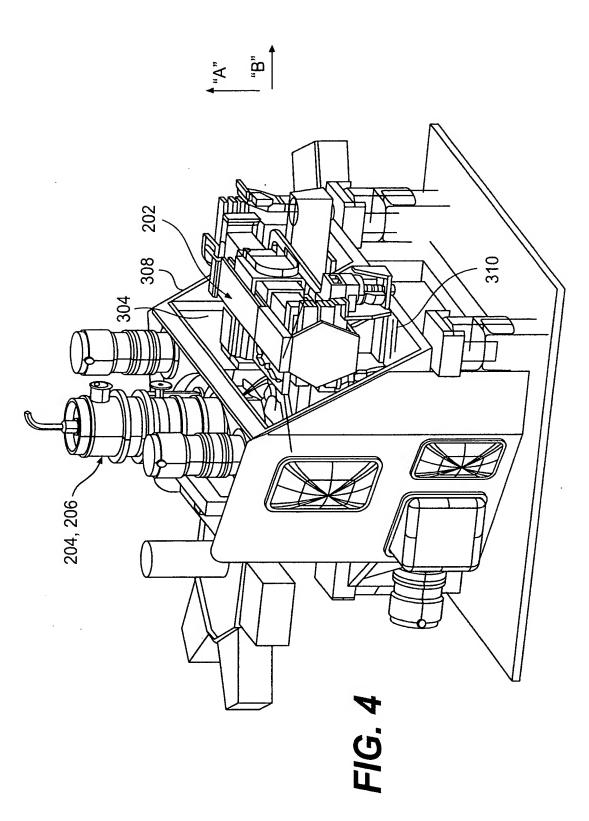


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